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CONFIRMATION NO. 6791

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/517,765	02/03/2006	438	2813	040509

APPLICANTS Takashi Ozaki, Nakano-ku, JAPAN; Kenichi Suzuki, Nakono-ku, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08097 06/26/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-187566 06/27/2002 JAPAN 2003-084774 03/26/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/14/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /SONYA D MCCALL SHEPARD/ Acknowledged _____ Examiner's signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 12	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 6

ADDRESS KRATZ, QUINTOS & HANSON, LLP 1420 K Street, N.W. Suite 400 WASHINGTON, DC 20005 UNITED STATES		
TITLE Substrate treating apparatus and method for manufacturing semiconductor device		

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